



**THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **Manabu NAKAMURA et al.**

Group Art Unit: **2891**

Application Number: **10/659,748**

Examiner: **Bradley Smith**

Filed: **September 11, 2003**

Confirmation Number: **3468**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE  
HAVING GATE OR TUNNEL INSULATION FILM (As Amended)**

Attorney Docket Number: **031140**

Customer Number: **38834**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

July 9, 2007

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated March 7, 2007 for one month(s) from June 7, 2007 to July 7, 2007.

Attached please find a check in the amount of \$120.00 for the cost of the extension.

If any additional fees are due in connection with this paper, please charge Deposit Account No. 50-2866.

Respectfully submitted,

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